

Piezo Nanopositioner

High-Load Piezo-Driven Nanopositioner with Direct Position Measuring



P-750

- 1 nm lateral guiding accuracy
- Frictionless, high-precision flexure guiding system
- Load capacity 5 to 10 kg (depending on mounting orientation)
- Resolution <1 nm
- Direct metrology with capacitive sensors for highest precision
- Direct drive for fast response
- Travel range 75 μm
- Outstanding lifetime due to PICMA* piezo actuators

Outstanding lifetime due to PICMA® piezo actuators

The PICMA* piezo actuators are all-ceramic insulated. This protects them against humidity and failure resulting from an increase in leakage current. PICMA* actuators offer an up to ten times longer lifetime than conventional polymer-insulated actuators. 100 billion cycles without a single failure are proven.

Subnanometer resolution with capacitive sensors

Capacitive sensors measure with subnanometer resolution without contacting. They guarantee excellent linearity of motion, long-term stability, and a bandwidth in the kHz range.

High guiding accuracy due to zero-play flexure guides

Flexure guides are free of maintenance, friction, and wear, and do not require lubrication. Their stiffness allows high load capacity and they are insensitive to shock and vibration. They work in a wide temperature range.

Maximum accuracy due to direct position measuring

Motion is measured directly at the motion platform without any influence from the drive or guide elements. This allows optimal repeatability, outstanding stability, and stiff, fast-responding control.

Motion	Unit	Toleran- ce	P-750.20
Active axes			X
Travel range in X	μm		75
Travel range in X, open loop, at -20 to 120 V	μm	+20 / -0 %	75
Roll (Rotational crosstalk in θX with motion in X)	μrad	Тур.	±10
Pitch (Rotational crosstalk in θY with motion in X)	μrad	Тур.	±10

Positioning	Unit	Toleran- ce	P-750.20
Resolution in X, open loop	nm	Тур.	0.4
Integrated sensor			Capacitive, direct position measuring
System resolution in X	nm		1



Drive Properties	Unit	Toleran- ce	P-750.20
Drive type			Piezo actuator/PICMA®
Electrical capacitance in X	μF	±20%	7.7

Mechanical Properties	Unit	Toleran- ce	P-750.20
Resonant frequency in X, unloaded	Hz	±20%	600
Resonant frequency in X, under load with 10 kg	Hz	±20%	120
Permissible push force in X	N	Max.	100
Permissible push force in Z	N	Max.	100
Permissible pull force in X	N	Max.	50
Permissible pull force in Z	N	Max.	100
Guide			Flexure guide with lever amplification
Overall mass	kg		2.55

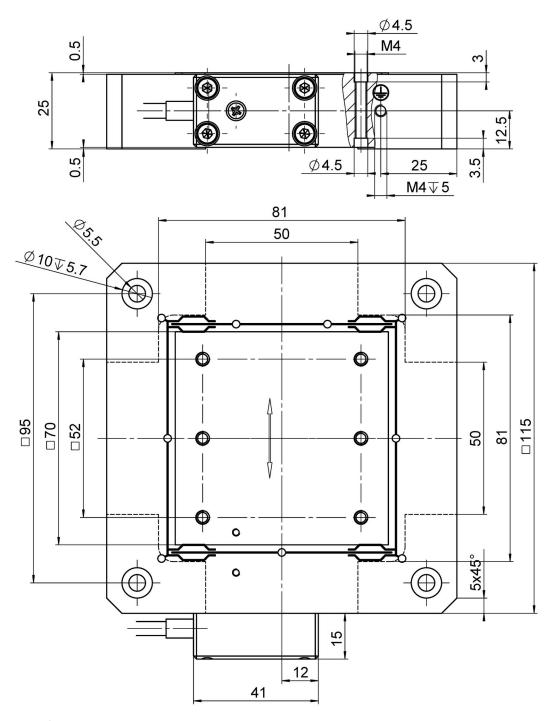
Miscellaneous	Unit	P-750.20
Operating temperature range	°C	19 to 25
Connector		LEMO FFS.00.250.CTCE24
Sensor connector		LEMO FFA.00.250.CTLC31
Cable length	m	1
Recommended controllers / drivers		E-500 • E-501, E-610, E-621, E-625, E-665, E-709, E-754

Resonant frequency in X, under load with 10 kg: With horizontally aligned motion platform.

The resolution of the system is limited only by the noise of the amplifier and the measuring technology because PI piezo nanopositioning systems are free of friction.



Drawings / Images



P-750, dimensions in mm

Order Information

P-750.20

Piezo nanopositioner; 75 µm travel range; capacitive, direct position measuring; LEMO connectors; 1 m cable length